



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

May 11, 2026	
IGI Report Number	LG795697989
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND MIXED CUT
Measurements	6.92 - 6.93 X 4.45 MM

GRADING RESULTS

Carat Weight	1.51 CARAT
Color Grade	E
Clarity Grade	VS 1

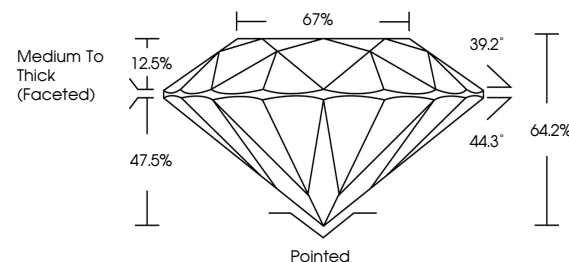
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	15 LG795697989

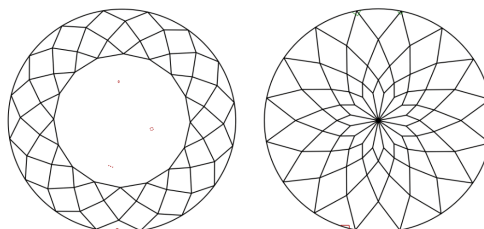
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG795697989
Report verification at lgi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

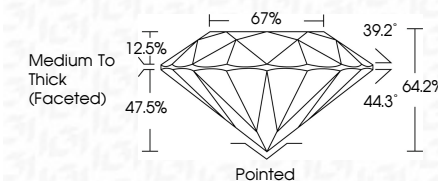
D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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www.igi.org

May 11, 2026

6.92 - 6.93 X 4.45 MM	1.51 CARAT
Color Weight	VS 1
Color Grade	64.2%
Clarity Grade	67%
Depth	Medium to Thick (faceted)
Table	Pointed
Grade	EXCELLENT
Clarity	EXCELLENT
Polish	NONE
Symmetry	EXCELLENT
Fluorescence	None
Comments	see pictures

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created by Chemical Vapor Deposition
(CVD) growth process.